INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 27, 2026

IGI Report Number	LG850697510
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	10.21 X 7.18 X 4.81 MM

GRADING RESULTS

Carat Weight	3.50 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

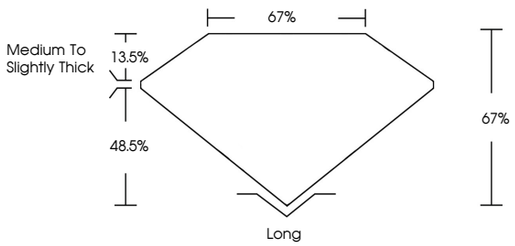
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG850697510

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG850697510
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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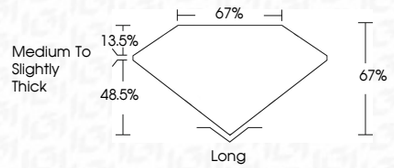

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IGI

October 27, 2026
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EMERALD CUT
10.21 X 7.18 X 4.81 MM
Carat Weight 3.50 CARATS
Color Grade E
Clarity Grade VVS 2
Cut Grade EXCELLENT
Depth 67%
Table 67%
Girdle Medium To Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG850697510
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa